

## INFORMATION DISCLOSURE CITATION

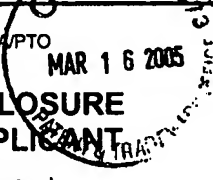
Atty. Docket No.	04284.0878	Serial No.	<del>Not Yet Assigned</del> 10/765,122
Applicants	Yasunobu YAMAUCHI et al.		
Filing Date	January 28, 2004	Group:	<del>Not Yet Assigned</del> 2624

U.S. PATENT DOCUMENTS							
Examiner Initial*		Document Number	Issue Date	Name	Class	Sub Class	Filing Date If Appropriate
/JWL/		6,097,394	08/01/00	LEVOY et al.			
/JWL/		6,297,834 B1	10/02/01	MALZBENDER			

FOREIGN PATENT DOCUMENTS							
		Document Number	Publication Date	Country	Class	Sub Class	Translation Yes or No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	
/JWL/	LEVOY, M. et al., "Light Field Rendering", Proceedings of ACM SIGGRAPH 1996, pp. 31-42, (1996).
↓	GORTLER, S. J. et al., "The Lumigraph", Proceedings of ACM SIGGRAPH 1996, pp. 43-54, (1996).
↓	CHEN, W. C. et al., "Light Field Mapping: Efficient Representation and Hardware Rendering of Surface Light Fields", Proceedings of ACM SIGGRAPH 2002, pp. 447-456, (2002).
↓	DANA, K. J. et al., "Reflectance and Texture of Real-World Surfaces", IEEE Computer Society Conference on Computer Vision and Pattern Recognition, pp. 151-157, (1997).

Examiner	/John Lee/	Date Considered	05/18/2007
*Examiner:	Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.		
Form PTO 1449	Patent and Trademark Office - U.S. Department of Commerce		



IDS Form PTO/SB/08: Substitute for form 1449/PTO

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

(Use as many sheets as necessary)

**Complete if Known**

Application Number	10/765,122
Filing Date	January 28, 2004
First Named Inventor	Yasunobu Yamauchi
Art Unit	/JWL/ <del>2641</del> <b>2624</b>
Examiner Name	/JWL/ <del>John W. Lee</del> <b>John W. Lee</b>
Attorney Docket Number	7906.0028

Sheet

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of

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U.S. PATENTS AND PUBLISHED U.S. PATENT APPLICATIONS					
Examiner Initials	Cite No. <sup>1</sup>	Document Number	Issue or Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>2</sup> (if known)			
/JWL/		US-2004-0212625 A1	10/28/04	Sekine et al.	
/JWL/		US-2004-0041816 A1	3/4/04	Yamauchi et al.	
		US-			
		US-			
		US-			
		US-			

**Note: Copies of the U.S. Patent Documents are not Required in IDS filed after October 21, 2004**

FOREIGN PATENT DOCUMENTS						
Examiner Initials	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Translation <sup>6</sup>
		Country Code <sup>3</sup> Number <sup>4</sup> Kind Code <sup>5</sup> (if known)				

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	Translation <sup>6</sup>

Examiner Signature	/John Lee/	Date Considered	05/18/2007
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